

Notice of References Cited	Application/Control No. 10/573,635	Applicant(s)/Patent Under Reexamination HATTORI ET AL.	
	Examiner Jason L. Savage	Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0009366	01-2004	Takagi et al.	428/653
*	B	US-2001/0016268	08-2001	MAKI et al.	428/653
*	C	US-5,789,089	08-1998	Maki et al.	428/623
*	D	US-4,913,785	04-1990	Uchida et al.	205/193
*	E	US-4,891,274	01-1990	Higuchi et al.	428/653
*	F	US-4,729,929	03-1988	Shinoda et al.	428/653
*	G	US-4,003,766	01-1977	Ito et al.	148/24
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	JP 2005-319481 English Machine Translation, Hattori et al, 11-2005
	V	JP 2003-145278 English Machine Translation, lwase et al, 05-2003
	W	JP 05-065503 English Machine Translation, Maejima et al, 03-1993
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.